

QCO.091A/061121

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Wen-Jian Lin  
Appl. No. : 10/810,660  
Filed : March 29, 2004  
For : STRUCTURE OF A MICRO  
ELECTRO MECHANICAL  
SYSTEM AND THE  
MANUFACTURING METHOD  
THEREOF  
Examiner : Jarrett J. Stark  
Group Art Unit : 2823

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May 17, 2007

(Date)



Ryan E. Melnick, Reg. No. 58,621

RESPONSE TO FINAL OFFICE ACTION

**Mail Stop AF**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

In response to the Final Office Action mailed March 22, 2007, please find the enclosed  
remarks.

**A Listing of the Claims** begins on page 2 of this paper.

**Remarks/Arguments** begin on page 9 of this paper.